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NGC-212/12-1167

**IN THE UNITED STATES  
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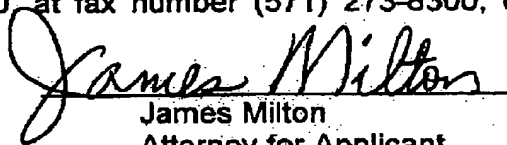
**Patent Application**

**Inventor(s):** Raffi Nazare Elmadjian  
**Case No.:** NGC-212/12-1167  
**Serial No.:** 10/688,238  
**Filing Date:** 10/18/2003  
**Title:** WAFER ETCHING TECHNIQUES

**Examiner** Ken Chan Chin  
**Art Unit:** 1765

**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being sent via facsimile transmission to Commissioner for Patents, Mail Stop RCE, Group Art Unit 1765, Attention: Examiner Ken Chan Chin, P.O. Box 1450, Alexandria, VA 22313-1450, at fax number (571) 273-8300, on February 20, 2006.



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Date of Signature: February 20, 2006

Commissioner for Patents  
Mail Stop RCE  
Group Art Unit 1765  
Attention: Examiner Ken Chan Chin  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Fax Number (571) 273-8300

**PRELIMINARY AMENDMENT**

Dear Sir:

This paper is filed in response to the Final Office Action mailed November 10, 2005 and the Advisory Action mailed on February 14, 2005 in connection with the above-designated application. The six-month period for responding to the final Office Action expires on May 10, 2005. Therefore, this Response is timely filed within the six-month period.